

www.sughrue.com



Peter D. Olexy T 202-663-7913 P0lexy@sughrue.com

July 14, 2003



MAIL STOP PATENT APPLICATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Re:

Application of Kenji DATE and Masumi NAKAI

POROUS SINTERED METAL AND FILTER THEREOF, AND METHOD FOR

PRODUCING POROUS SINTERED METAL

Assignee: HITACHI METALS, LTD.

Our Ref. Q76503

Dear Sir:

Attached hereto is the application identified above comprising thirty four (34) sheets of the specification, including the claims and abstract, nine (9) sheets of drawings, and executed assignment, and executed Declaration and Power of Attorney.

The Government filing fee is calculated as follows:

TOTAL FEE						\$750.00
Independent claims Base Fee		=	. X	\$84.00	= _	\$.00 \$750.00
Total claims	12 - 20	=	. X	\$18.00	= _	\$.00

A check for the statutory filing fee of \$750.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this transmittal letter is attached.



MAIL STOP PATENT APPLICATION

July 14, 2003 Page 2

Priority is claimed from:

Country

Application No

Filing Date

JAPAN

2002-205958

July 15, 2002

JAPAN

2003-95376

March 31, 2003

The priority documents will be filed at a later date.

Respectfully submitted, SUGHRUE MION, PLLC

Attorneys for Applicant

Peter D. Olexy

Registration No. 24,513

SUGHRUE MION, PLLC

Telephone: (202) 293-7060 Facsimile: (202) 293-7860

WASHINGTON OFFICE

233/3
PATENT TRADEMARK OFFICE

PDO/ars